

Interference Search History

M T

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|------|---|---|------------------|---------|------------------|
| L1 | 1 | (nanomechanical near structures and energy near beam and wet near etchant).CLM. | US-PGPUB; USPAT; USOCR; EPO; JPO | OR | OFF | 2005/12/02 10:00 |